



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Group Art Unit: 2851

Application No.: 09/769,832

Examiner: R. FULLER

Filed: January 26, 2001

Docket No.: 108455

For: PROJECTION EXPOSURE APPARATUS AND METHOD, CATADIOPTRIC OPTICAL
SYSTEM AND MANUFACTURING METHOD OF DEVICES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.
- ☒ 2. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 3. An English language Abstract of one or more non-English language reference is attached hereto. See Reference 8.
- ☒ 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 8.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

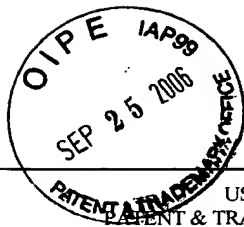
MAC/ccs
Date: September 25, 2006
OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

Sheet 1 of 2

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 108455		APPLICATION NO. 09/769,832	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Yasuhiro OMURA et al.			
				FILING DATE January 26, 2001		GROUP 2851	
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	2002/0145711 A1	10-10-2002	Magome et al.			
	2	2002/0196533 A1	12-26-2002	Shafer et al.			
	3	2003/0020888 A1	01-30-2003	Tanaka et al.			
	4	2004/0104359 A1	06-03-2004	Komatsuda et al.			
	5	5,689,377	11-18-1997	Takahashi			
	6	5,694,241	12-2-1997	Ishiyama et al.			
	7	5,805,334	09-08-1998	Takahashi			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	8	JP-A-7-168116	07-04-1995	Japan	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: September 25, 2006

Sheet 2 of 2Form PTO-1449
(REV. 1/06)US Dept. of Commerce
PATENT & TRADEMARK OFFICEATTY DOCKET NO.
108455APPLICATION NO.
09/769,832

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S)
Yasuhiro OMURA et al.FILING DATE
January 26, 2001GROUP
2851

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Name
	9	5,969,441	10-19-1999	Loopstra et al.
	10	6,246,204 B1	06-12-2001	Ebihara et al.
	11	6,249,382 B1	06-19-2001	Komatsuda
	12	6,262,796 B1	07-17-2001	Loopstra et al.
	13	6,327,022 B1	12-4-2001	Nishi
	14	6,337,162 B1	01-08-2002	Irie
	15	6,341,007 B1	01-22-2002	Nishi et al.
	16	6,677,088 B2	01-13-2004	Magome et al.

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation

OTHER DOCUMENTS

Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: September 25, 2006